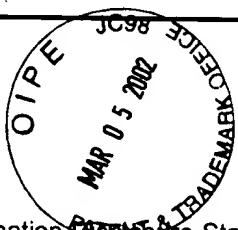


TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))Docket No.
SEC.689

In Re Application Of: Chan Hoon PARK et al.

Serial No.	Filing Date	Examiner	Group Art Unit
09/484,051	18 January 2000	C. Atkinson	3743

Title: WAFER HEATING APPARATUS HAVING FLUID HEAT TRANSFER MEDIUM AND METHOD OF
HEATING A WAFER USING THE SAME



Address to:

Assistant Commissioner for Patents
Washington, D.C. 20231

37 CFR 1.97(b)

1. The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

37 CFR 1.97(c)

2. The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

the statement specified in 37 CFR 1.97(e);

OR

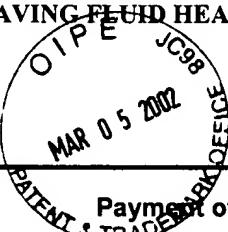
the fee set forth in 37 CFR 1.17(p).

3. Also enclosed are (a) a copy of an 6 December 2001, Notice To Submit Response which issued by the Korean Patent Office in connection with the Korean priority application, and (b) an English-Language translation of said Notice

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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))
Docket No.
SEC.689

In Re Application: Chan Hoon PARK et al.

Serial No.
09/484,051Filing Date
18 January 2000Examiner
C. AtkinsonGroup Art Unit
3743
WAFER HEATING APPARATUS HAVING FLUID HEAT TRANSFER MEDIUM AND METHOD
HEATING A WAFER USING THE SAME
**Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- A check in the amount of _____ is attached.
- The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. _____ as described below. A duplicate copy of this sheet is enclosed.
- Charge the amount of _____
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I certify that this document and authorization to charge deposit account is being facsimile transmitted to the United States Patent and Trademark Office (F)

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I certify that this document and fee is being deposited with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

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Signature

KENNETH D. SPRINGER

REG. NO.: 39,843

VOLENTINE FRANCOS, P.L.L.C.
12200 SUNRISE VALLEY DRIVE, SUITE 150
RESTON, VIRGINIA 20191

TEL. NO.: (703) 715-0870

CC:

Dated: 5 MARCH 2002

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STATEMENT UNDER 37 CFR 1.97(e) ACCOMPANYING
INFORMATION DISCLOSURE STATEMENTDocket No.
SEC.689

In Re Application Of: Chan-Hoon PARK et al.

Serial No.
09/484,051Filing Date
18 January 2000Examiner
C. AtkinsonGroup Art Unit
3743Invention: WAFER HEATING APPARATUS HAVING FLUID HEAT TRANSFER MEDIUM AND METHOD OF
HEATING A WAFER USING THE SAMERECEIVED
MAR 12 2002
TECHNOLOGY CENTER 3700TO THE ASSISTANT COMMISSIONER FOR PATENTS:

This is a statement under the provisions of 37 CFR 1.97(e) in the above-identified application.

Check applicable statement herebelow:

Statement Under 37 CFR 1.97(e)(1)

- Each item of information contained in the accompanying Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement.

Statement Under 37 CFR 1.97(e)(2)

- No item of information contained in the accompanying Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned person, after making reasonable inquiry, no item of information contained in the accompanying Information Disclosure Statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the Information Disclosure Statement.



Signature

Dated: 5 March 2002

KENNET H D. SPRINGER
REG. NO.: 39,843VOLENTINE FRANCOS, P.L.L.C.
12200 SUNRISE VALLEY DRIVE, SUITE 150
RESTON, VIRGINIA 20191

TEL. NO.: (703) 715-0870

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I certify that this document is being deposited on **March 12, 2002** with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

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